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				APPLICANT Eugene P. Marsh				
				FILING DATE October 19, 1999		GROUP 2811		
U.S. PATENT DOCUMENTS								
*Examiner Initial		Document Number	Date	Name		Class	Subclass	Filing Date If Appropriate
	AA							
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		Document Number	Date	Country	Class	Subclass	Translation	
	AM						Yes	No
	AN							
	AO							
	AP							
	AO							
OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)								
✓	AR	Toru Nasu, et al, Study of Pt Bottom Electrodes Using High-Temperature Sputtering for Ferroelectric Memories with SrBi ₂ Ta ₂ O ₉ (SBTO) Film, Jpn. J. Appl. Phys. Vol. 37 (1998) pp. 4144-4148.						
	AS							
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